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April 5, 2005
Date

Ayesha J. Shaikh
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/699,256

Confirmation No. : 9603

Applicants : Chih-Chen Cho and Zhongze Wang

Filed : October 30, 2003

Attorney Docket No.: 500982.02 (30016/US/2)

Art Unit : 2822

Customer No. : 27,076

Examiner : Toniae M. Thomas

Title : METHODS FOR MAKING SEMICONDUCTOR STRUCTURES HAVING HIGH-SPEED AREAS AND HIGH-DENSITY AREAS

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Restriction Requirement dated March 23, 2005, applicants hereby elect Group I, claims 1-18 and 25-44, for examination at this time.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 9 of this paper.